

<b>Notice of References Cited</b>	Application/Control No. 00/020,275/01773, 879	Applicant(s)/Patent Under Reexamination CHRYSLER ET AL.	
	Examiner Scott B. Geyer	Art Unit 2829 2818	Page 1 of 1

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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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*David B. Geyer*

12/12/04

# Notice of References Cited

Application/Control No.

09/920,275 10/773,879

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Reexamination  
CHRYSLER ET AL.

Examiner

Scott B. Geyer

Art Unit

2829 2818

Page 1 of 1

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	Examiner Scott B. Geyer	Art Unit <u>2820</u> <u>25818</u>	Page 1 of 1

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Art Unit

2829 2818

Page 1 of 1

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12/12/04